

# **«Saint Petersburg OPEN 2020»**



## **BOOK of ABSTRACTS**

**7<sup>th</sup> International School and Conference  
on Optoelectronics, Photonics,  
Engineering and Nanostructures**

**April 26-30, 2020 • Saint Petersburg, Russia**

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# **dV/dt testing of high voltage 4H-SiC Schottky diodes with different types of metal-polymeric packages**

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**Abstract.** The  $dV/dt$  values for 4H-SiC Schottky type diodes with different type packages have been determined experimentally. It is determined that obtained  $dV/dt$  values for 4H-SiC Schottky type diodes in small-sized metal-polymeric packages (SOT, QFN) are varying in interval of 670÷990 V/ns.

## **Introduction**

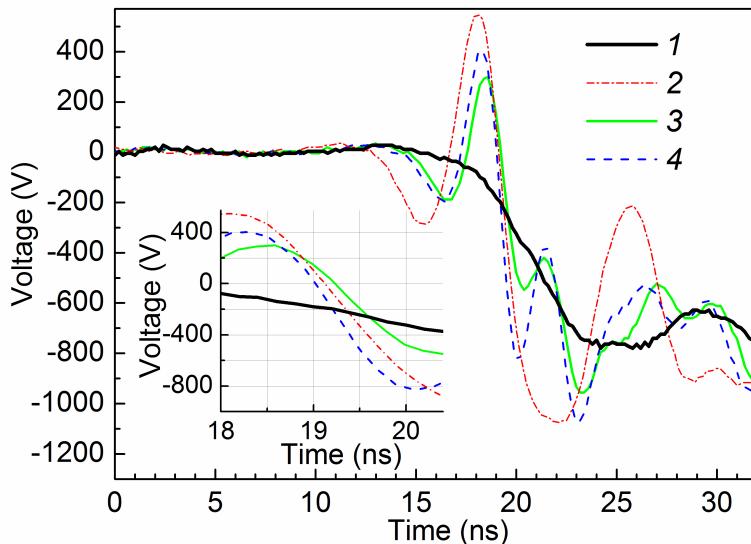
At present the SiC-based high-voltage Schottky type diodes are based on absolutely new generation of power semiconductors, posses the maximal values of breakdown voltage and minimal leakage currents [1]. Earlier, in our previous studies were investigated 4H-SiC Schottky type diodes in respect of their stability to rate of reverse voltage rise  $dV/dt$  [2]. In particular, it was established that in 4H-SiC Schottky diodes packaged in standard large-sized package of TO (Transistor Outline) type demonstrate the value of  $dV/dt \approx 150\text{--}200$  V/ns [2]. It is known that the diode package is one of the main elements that determines the characteristics of the diode [3]. Moreover, at present power electronic industry comes down to use of small-sized type of metal-polymeric package such as SOT (Small Outline Transistor), QFN (Quad Flat No-leads) and others [1,3]. However, effect of packaging type on  $dV/dt$  characteristics of 4H-SiC Schottky diodes to present are almost not studied, therefore the goal of this work is to study  $dV/dt$  characteristics for Schottky diodes in different types of packages.

## **2. Materials and methods**

The used experimental measuring test makes it possible to test on  $dV/dt$  characteristics of a SiC Schottky type diodes which was described in detail earlier [2]. The main parameters of tester of  $dV/dt$  value in interval from 100 V/ns up to 1000 V/ns at amplitude of pulse of reverse voltage applied through a testing diode  $V_A = 0.05\text{--}0.9$  kV. Analyses of oscillograms has been carried out with used Tektronix MDO3102 oscilloscope (bandwidth 1 GHz, refresh rate  $5 \times 10^9$  s<sup>-1</sup>).

## **3. Results and discussion**

To prevent experimental errors, the equipment was initially calibrated with a control signal from the equipment by applied amplitude of pulse of reverse voltage (maximal amplitude of 0.7 kV) without diode which is shown in Fig. 1 (curve 1). Then, were tested the following 4H-SiC type Schottky diodes: diode C3D06060F (CREE/Wolfspeed, US) in large-sized TO package type (TO-220-F2); diode 5DS402A (AO «GRUPPA KREMNY EL», Bryansk, Russia) in small-sized SOT package type (SOT-89); diode C3D1P7060Q (CREE/Wolfspeed, US) in small-sized QFN package type (PowerQFN). All obtained  $dV/dt$  test results for diodes are shown in Table 1.



**Figure 1.** The reverse voltage waveform for diodes (pulse amplitude of 0.7 kV): 1 – without diode, 2 – C3D06060F (Cree), 3 – 5DS402A9 («GRUPPA KREMNY EL»), 4 – C3D1P7060Q (Cree).

The obtained  $dV/dt$  value for diode C3D06060F (curve 2 in Fig. 1) in large-sized TO package is equal of 880 V/ns. The testing results for diode 5DS402A (curve 3 in Fig. 1) in small-sized SOT package type is equal of 670 V/ns and for C3D1P7060Q (curve 4) in small-sized QFN package is 990 V/ns.

**Table 1.**  $dV/dt$  results for testing of 4H-SiC Schottky diodes with different packages type.

| No. | Package type | Diode's type | Package dimensions (mm) | $dV/dt$ (V/ns) |
|-----|--------------|--------------|-------------------------|----------------|
| 1   | TO-220-F2    | C3D06060F    | 10.3×16.07              | 880            |
| 2   | SOT-89       | 5DS402A      | 4.6×2.6                 | 670            |
| 3   | QFN 3.3      | C3D1P7060Q   | 3.3×3.3                 | 990            |

#### 4. Conclusions.

The obtained results indicated that the package's size miniaturization not lead to  $dV/dt$  characteristics degradation and  $dV/dt$  values for small-sized metal-polymeric packages type (SOT, QFN) not only are comparable with large-sized TO package type, but in case of QFN package type the  $dV/dt$  results are greater than in case of the large-sized TO package.

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